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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s): GOTOU, et al.
Application No.: 09/965,221
Filed: September 28, 2001
For: METHOD OF MANUFACTURING A SEMICONDUCTOR DEVICE
Group: 1732
Examiner: C. Lattin

AMENDMENT

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

August 3, 2004

Sir:

In response to the Office Action mailed March 3, 2004, please amend the above-identified application as listed in the following, and as set forth on the following pages:

Amendments to the Claims; and

Remarks are included following the amendments.